3P \$40 00 1244293

PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Junya Ishida	03/19/2009
Katsunori Iwase	03/23/2009
Akira Yamamoto	03/26/2009
Masahiko Minemura	03/23/2009

RECEIVING PARTY DATA

Name:	Shin-Etsu Polymer Co., Ltd.
Street Address:	3-5, Nihonbashi-honcho 4 chome
City:	Chuo-ku, Tokyo
State/Country:	JAPAN
Postal Code:	103-0023

Name:	Denso Corporation
Street Address:	1-1, Showa-cho
City:	Kariya-shi, Aichi
State/Country:	JAPAN
Postal Code:	448-8661

Name:	Shin-Etsu Chemical Co., Ltd.
Street Address:	6-1, Ohtemachi 2-chome
City:	Chiyoda-ku, Tokyo
State/Country:	JAPAN
Postal Code:	100-0004

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12442933

CORRESPONDENCE DATA

PATENT REEL: 022669 FRAME: 0005 Fax Number: (713)228-8778

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Total Attachments: 4

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> PATENT REEL: 022669 FRAME: 0006

ASSIGNMENT

Whereas, I/we, Address Name c/o Shin-Etsu Polymer Co., Ltd., 1) Junya ISHIDA 406-1, Yoshino-cho 1-chome, Kita-ku, Saitama-shi, Saitama 331-0811 Japan c/o DENSO CORPORATION, 1-1, Showa-cho, Kariya-shi, Aichi 448-8661 Japan 2) Katsunori IWASE c/o Silicone-Electronics Materials Research Center of Shin-Etsu Chemical Co., Ltd., 1-10, Hitomi, Matsuida-machi, Annaka-shi, Gunma 379-0224 Japan 3) Akira YAMAMOTO c/o Silicone-Electronics Materials Research Center of Shin-Etsu Chemical Co., Ltd., 4) Masahiko MINEMURA 1-10, Hitomi, Matsuida-machi, Annaka-shi, Gunma 379-0224 Japan hereinafter called assignor(s), have invented certain improvements in SELECTIVELY PERMEABLE MATERIAL, METHOD FOR PRODUCING SELECTIVELY PERMEABLE MEMBRANE STRUCTURE, SELECTIVELY PERMEABLE MEMBRANE STRUCTURE, AND AIR CONDITIONING SYSTEM and executed an application for Letters Patent of the United States of America therefor on even date herewith unless otherwise indicated below: March 25, 2009 12/442933 , Serial No. : and filed on Whereas Shin-Etsu Polymer Co., Ltd. 3-5, Nihonbashi-honcho 4-chome, Chuo-ku, Tokyo 103-0023 Japan and, **DENSO CORPORATION** 1-1, Showa-cho, Kariya-shi, Aichi 448-8661 Japan and. Shin-Etsu Chemical Co., Ltd. 6-1, Ohtemachi 2-chome Chiyoda-ku, Tokyo 100-0004 Japan

(assignee), desires to acquire the entire right, title and interest in the application and invention, and to any United States patents to be obtained therefor;

NOW THEREFORE, be it known that, for good and valuable consideration from assignee, the receipt of which is hereby acknowledged, I/WE, as assignor(s), have sold, assigned, transferred, and set over, and do hereby sell, assign, transfer, and set over unto the assignee, its lawful successors and assigns, MY/OUR entire right, title, and interest in and to this invention and this application, and all divisions, and continuations thereof, and all Letters Patent of the United States which may be granted thereon, and all reissues thereof; and I/WE hereby authorize and request the Commissioner of Patents and Trademarks of the United States to issue all Letters Patent for this invention to assignee, its successors and assigns, in accordance with the terms of this Assignment;

AND, I/WE HEREBY further covenant and agree that I/WE will, without further consideration, communicate with assignee, its successors and assigns, any facts known to ME/US respecting this invention and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver all papers that may be necessary or desirable to perfect the title to this invention in said assignee, its successors and assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States, it being understood that any expense incident to the execution of such papers shall be borne by the assignee, its successors and assigns.

DATE SIGNED	
larch 12009	
-	

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)

ASSIGNMENT

Whereas, I/we, Address <u>Name</u> c/o Shin-Etsu Polymer Co., Ltd., 406-1, Yoshino-cho 1-chome, Kita-ku, Saitama-shi, Saitama 331-0811 Japan 1) Junya ISHIDA c/o DENSO CORPORATION, 1-1, Showa-cho, Kariya-shi, Aichi 448-8661 Japan 2) Katsunori IWASE c/o Silicone-Electronics Materials Research Center of Shin-Etsu Chemical Co., Ltd., 3) Akira YAMAMOTO 1-10, Hitomi, Matsuida-machi, Annaka-shi, Gunma 379-0224 Japan c/o Silicone-Electronics Materials Research Center of Shin-Etsu Chemical Co., Ltd., 4) Masahiko MINEMURA 1-10, Hitomi, Matsuida-machi, Annaka-shi, Gunma 379-0224 Japan hereinafter called assignor(s), have invented certain improvements in SELECTIVELY PERMEABLE MATERIAL, METHOD FOR PRODUCING SELECTIVELY PERMEABLE MEMBRANE STRUCTURE, SELECTIVELY PERMEABLE MEMBRANE STRUCTURE, AND AIR CONDITIONING SYSTEM and executed an application for Letters Patent of the United States of America therefor on even date herewith unless otherwise indicated below: March 25, 2009 Serial No. 12/442933 filed on Whereas Shin-Etsu Polymer Co., Ltd. 3-5, Nihonbashi-honcho 4-chome,

DENSO CORPORATION

and,

1-1, Showa-cho, Kariya-shi, Aichi 448-8661 Japan

Chuo-ku, Tokyo 103-0023 Japan

and, Shin-Etsu Chemical Co., Ltd.

6-1, Ohtemachi 2-chome,

Chiyoda-ku, Tokyo 100-0004 Japan

(assignee), desires to acquire the entire right, title and interest in the application and invention, and to any United States patents to be obtained therefor;

NOW THEREFORE, be it known that, for good and valuable consideration from assignee, the receipt of which is hereby acknowledged, I/WE, as assignor(s), have sold, assigned, transferred, and set over, and do hereby sell, assign, transfer, and set over unto the assignee, its lawful successors and assigns, MY/OUR entire right, title, and interest in and to this invention and this application, and all divisions, and continuations thereof, and all Letters Patent of the United States which may be granted thereon, and all reissues thereof; and I/WE hereby authorize and request the Commissioner of Patents and Trademarks of the United States to issue all Letters Patent for this invention to assignee, its successors and assigns, in accordance with the terms of this Assignment;

AND, I/WE HEREBY further covenant and agree that I/WE will, without further consideration, communicate with assignee, its successors and assigns, any facts known to ME/US respecting this invention and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver all papers that may be necessary or desirable to perfect the title to this invention in said assignee, its successors and assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States, it being understood that any expense incident to the execution of such papers shall be borne by the assignee, its successors and assigns.

Ū	INVENTORS	DATE SIGNED
1):		
Name:	Junya ISHIDA	
2):	Katsunori Iwase Katsunori IWASE	2007.03.23
Name:	Katsunori IWASE	
3):		
Name:	Akira YAMAMOTO	

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)

ASSIGNMENT

Whereas, I/we,

Name:

<u>Name</u>	<u>Address</u>	·
	c/o Shin-Etsu Polymer Co., Ltd.,	
1) Junya ISHIDA	406-1, Yoshino-cho 1-chome, Kita-ku, Saitama-shi, Saitama 331-0811 Japan	
	c/o DENSO CORPORATION,	
2) Katsunori IWASE	1-1, Showa-cho, Kariya-shi, Aichi 448-8661 Japan	
	c/o Silicone-Electronics Materials Research Center of	Shin-Etsu Chemical Co., Ltd.,
3) Akira YAMAMOTO 1-10, Hitomi, Matsuida-machi, Annaka-shi, Gunma 379-0224 Japan		
	c/o Silicone-Electronics Materials Research Center of	Shin-Etsu Chemical Co., Ltd.,
4) Masahiko MINEMURA	1-10, Hitomi, Matsuida-machi, Annaka-shi, Gunma 379-0224 Japan	
SELECTIVELY PERMEABLE MASTRUCTURE, SELECTIVELY PE	e invented certain improvements in TERIAL, METHOD FOR PRODUCING SEL RMEABLE MEMBRANE STRUCTURE, AN	D AIR CONDITIONING SYSTEM
otherwise indicated below:	tters Patent of the United States of America	
filed on	March 25, 2009 , Serial No	1 2 / 4 4 2 9 3 3 ; and
Shin-Etsu Polymer Co., Lt	honcho 4-chome,	
and, DENSO CORPORATION 1-1, Showa-cho, Kariya-shi, Aichi	448-8661 Japan	
and, Shin-Etsu Chemical Co., I 6-1, Ohtemachi 2 Chiyoda-ku, Toky		
patents to be obtained therefor; NOW THEREFORE, be it kn hereby acknowledged, I/WE, as as transfer, and set over unto the assi this invention and this application, a which may be granted thereon, and	and all divisions, and continuations thereof, d all reissues thereof; and I/WE hereby auth ited States to issue all Letters Patent for this	on from assignee, the receipt of which is and set over, and do hereby sell, assign, //OUR entire right, title, and interest in and to and all Letters Patent of the United States orize and request the Commissioner of
assignee, its successors and assig proceeding, sign all lawful papers v desirable to perfect the title to this i continuation, and reissue applications successors and assigns, to obtain a	covenant and agree that I/WE will, without fins, any facts known to ME/US respecting the when called upon to do so, execute and delimination in said assignee, its successors arons, make all rightful oaths and generally do and enforce proper patent protection for this ent to the execution of such papers shall be	is invention and testify in any legal ver all papers that may be necessary or nd assigns, execute all divisional, everything possible to aid assignee, its invention in the United States, it being
<u>INVENTORS</u>		DATE SIGNED
1): Name:	lumin ICUIDA	-
	Junya ISHIDA	
2): Name:	Katsunori IWASE	
·	in a Young ment or	March 26, 2009

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)

Akira YAMAMOTO

4): Name:

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)

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RECORDED: 05/12/2009

PATENT

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